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Amdt. Dated January 3, 2007

Response to Office Action of August 3, 2006

REMARKS/ARGUMENTS

Claims 1-31 are pending in the application. Claim 28 stands rejected under 35 U.S.C.

§ 102(e) as anticipated by Kan. The remaining claims stand rejected under 35 U.S.C. §

103(a) as unpatentable over Kan in view of various combinations of Chiba, Miyagawa, Ohba,

Kitai, Endo, Miguelez, and Richardson.

In response to the action, claims 1 and 10 have been amended. Claims 28-31 have

been cancelled. New claims 32-34 have been added. Reconsideration of the claims in view

of the amendments and the following remarks is respectfully requested.

§ 112 Rejection and Claim Objections

Claim 26 and claim 17 have been amended to correct the problems noted in the

action. In view of these corrections, the Applicants respectfully request that the rejection of

these claims be withdrawn.

§ 103 Rejections

Pending claims 1-27 have been rejected under 35 USC § 103 as unpatantable over

Kan in view of various other references. Reconsideration of these claims in view of the

amendments and the following remarks is respectfully requested.

Claim 1, as amended, recites a method for marking a target media using a microlaser

which, upon reaching an absorbed power saturation threshold, emits a high peak power pulse

of light. The method includes the steps of driving the microlaser at a simmer power level

selected to maintain the microlaser below the saturation threshold and to limit the activation

time of the microlaser, directing the microlaser at the target media on which the mark is to be

made, and increasing the power applied to the microlaser to the saturation threshold to cause

the microlaser to emit a pulse of light for forming the mark. During the simmer mode, a

current, voltage, and temperature of the microlaser are monitored to maintain the microlaser

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at predetermined power levels. The feedback monitoring allows the power level to be

maintained within very specific tolerance ranges over long simmer time periods, therefore

maintaining tight tolerance on the size of the pulse formed, and allowing significant control

over the size of the mark, which is very important in providing quality print functions.

Kan discloses a method for controlling a laser in which the laser is maintained at a

level below saturation during a first time period, and is driven above saturation in a second

time period to provide a pulse output. A controller 42 controls the level of the current applied

to the laser to drive the laser below and above the saturation values. The preferred time

periods for the first and second periods are described as between 100 and 500 microseconds

and 1 to 10 microseconds (paragraph 35), and these times can be adjusted to control "constant

oscillation intervals" (paragraph 44). Kan, therefore, discloses a system in which the

intervals between pulses are short, and intended to provide ongoing oscillations at defined

periods. The control system merely adjusts the current levels to change state.

Kan, therefore, provides a simple control system for providing pulses over very short

intervals. Kan does not disclose, teach, or suggest the use of the laser for printing

applications, or the process of monitoring voltage, temperature, or current feedback during

the below saturation stage, as recited in the amended claim. As none of the other references

teach or suggest maintaining a laser at a level below saturation, these references cannot

disclose the step of monitoring feedback during this stage of operation. Therefore, the cited

references do not disclose all of the elements of claim 1, as amended, and the Applicants

respectfully request that the rejection of claim 1 and associated dependent claims be allowed.

Claim 10, as amended, recites a laser marking/imaging system comprising a passively

Q-switched microlaser having a saturable absorber which, upon reaching a saturation power

threshold, emits a pulse of light through an optical output. Control circuitry is electrically

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connected to the microlaser to monitor a current, a voltage, and a temperature feedback and

to maintain the microlaser in a simmer mode below the saturation power threshold when not

providing a mark, and for driving the microlaser to the saturation power threshold to emit a

pulse of light when a mark is required. A photodiode is electrically coupled to the microlaser

to provide feedback when the microlaser is activated to monitor the repetition rate of the

microlaser.

As discussed above, maintaining repeatable control over the power level of the

microlaser in the below saturation or simmer state is very important in providing consistently

sized pulses, and therefore for providing a quality and repeatable print. The printing device

of claim 10 provides this control by monitoring the voltage, current, and temperature

feedback in the simmer mode. The photodiode recited in claim 10, moreover, provides

additional control for the printing process by verifying the timing and size of the produced

mark.

Also as discussed above, the Kan reference does not disclose monitoring any

feedback during the time period when the laser is maintained below a saturation level. Kan,

moreover, does not teach or suggest that the resultant pulses can be used for printing or

marking. None of the remaining references teach or suggest maintaining the laser below the

saturation level. Therefore, claim 10, as amended, is believed to differentiate over the cited

references, and the Applicants respectfully request that the rejection of claim 10 and

associated dependent claims be allowed.

New Claims

New claims 32–34 provide a method for marking a target media using a microlaser

which, upon reaching an absorbed power saturation threshold, emits a high peak power pulse

of light. The method comprises the steps of driving the microlaser at a simmer power level

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selected to maintain the microlaser below the saturation threshold and to limit the activation

time of the microlaser, and monitoring a current, a voltage, and a temperature feedback and

adjusting the power applied to the microlaser to maintain the microlaser at a predetermined

power level. These steps are continually repeated until a command is received to form a

mark. A microlaser is then directed at the target media on which the mark is to be made, and

the power is increased to cause the microlaser to emit a pulse of light for forming the mark.

The applied power is then decreased to the simmer level after the mark is formed and the user

returns to monitoring feedback and input commands until a command for another mark is

formed.

None of the cited references disclose a method in which a laser is maintained below a

saturation level for an indeterminate period of time pending a command to print. None of the

cited references, moreover, disclose a simmer mode in which voltage, current, and

temperature feedback are continually controlled, or the use of a "simmer mode" during a

printing or marking process. Therefore, new claims 32-34 are believed patentable over the

cited references and the Applicants respectfully request that a notice of allowance for these

claims be issued.

Conclusion

In view of the foregoing amendments and remarks, the Applicants submit that the

application is in condition for allowance, and respectfully request that a notice of allowance

for claims 1-27 and 32-34 be issued.

A two month extension is believed necessary in accordance with this response. A

check for these fees is closed. Please charge any other fees under 37 CFR § 1.17 that may be

due on this application to Deposit Account 17-0055. The Commissioner is also authorized to

treat this amendment and any future reply in this matter requiring a petition for an extension

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of time as incorporating a petition for extension of time for the appropriate length of time as provided by 37 CFR § 136(a)(3).

Respectfully submitted,

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Dated January 3, 2007

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